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**Title of
Invention****MULTILAYER STRUCTURE FOR ABSORBING ELECTROMAGNETIC
WAVE AND MANUFACTURING METHOD THEREOF**

Application Number :

Date :

First Named Applicant: Mr. Li-Hsien Yen

Confirmation Number:

Attorney Docket Number: 10026-US-PA-0C

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Submitted By:**Elec. Sign.****Sign. Capacity**

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Agent

Registered Number: 46,863

Documents being submitted:	Files
us-fee-sheet	10026CA-usfees.xml us-fee-sheet.xml us-fee-sheet.dtd
us-request	10026CA-usrequ.xml us-request.dtd us-request.xml
application-body	10026CA.xml application-body.dtd Image1.tif Image2.tif Image3.tif Image4.tif isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isogr1.ent isogr2.ent isogr3.ent isogr4.ent isolat1.ent isolat2.ent isomfrk.ent isomopf.ent isomscr.ent isonum.ent isopub.ent isotech.ent mathml2.dtd mathml2-qname-1.mod mmlalias.ent mmlextra.ent soextblx.dtd us-application-body.xml wipo.ent
application-body-pdf-wrap	10026CA-pdf-wrap.xml
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Comments	

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